

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PRELIMINARY AMENDMENT ACCOMPANYING APPLICATION

APPLICANT: Hiroshi Horikoshi, et al. ATTY. DOCKET NO. 09792909-5702
SERIAL NO. GROUP ART UNIT:
DATE FILED: October 7, 2003 EXAMINER:
INVENTION: "METHOD OF PRODUCING SEMICONDUCTOR DEVICE"

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

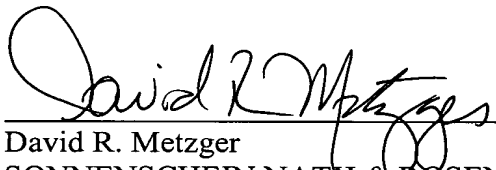
S I R:

Between the title and the heading "Background of the Invention" on page 1, insert the following:

--RELATED APPLICATION DATA

The present application claims priority to Japanese Application(s) No(s). P2002-299417 filed October 11, 2002, which application(s) is/are incorporated herein by reference to the extent permitted by law.--

Respectfully submitted,

 (Reg. No. 32,919)

David R. Metzger
SONNENSCHNATH & ROSENTHAL LLP
P.O. Box #061080
Wacker Drive Station - Sears Tower
Chicago, IL 60606-1080
Customer #26263

Attorneys for Applicant(s)